

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**RECEIVED
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Applicants: Heng Liu
Assignee: BridgeLux, Inc.
Title: Chemical Vapor Deposition Reactor
Application No.: 10/727,746 Filing Date: December 3, 2003
Examiner: Ram N. Kackar Group Art Unit: 1763
Docket No.: M-15626-1D US Confirmation No.: 8880

Irvine, California
February 25, 2008

Via Facsimile to (571) 273-8300

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action dated September 24, 2007, please amend the above-identified application as follows.